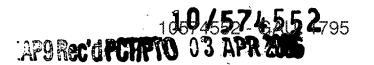
Receipt date: 04/03/2006



INFORMATION CITED BY APPLICANTS THAT MAY BE MATERIAL TO THE PROSECUTION OF THE SUBJECT APPLICATION

Applicants:

D.T. Schwartz et al.

Attorney Docket No.: UWOTL127258

Application No.: TO BE DETERMINED

Filed:

TO BE DETERMINED

Title:

ELECTROCHEMICAL MICROMANUFACTURING SYSTEM AND

METHOD

U.S. PATENT DOCUMENTS

*Examiner Initials	Cite No.	Document No.	Kind Code	Date (mm/dd/yyyy)	Name
	U1	5,641,391	Α	06/24/1997	Hunter et al.
	U2	6,027,630	Α	02/22/2000	Cohen
	_ U3	6,080,288	A	06/27/2000	Schwartz et al.
	U4	6,390,610	B1	05/21/2002	Hawkins et al.

FOREIGN PATENT DOCUMENTS

*Examiner Cite		77: 1	Publication Date		English	
Examiner Cite		Kind	Publication Date		Abstract	Translation
Initial No.	Document No.	Code	(mm/dd/yyyy)	Country	Provided	Provided

None

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

*Examiner	Cite
Initial	No.

None

Examiner

Date Considered

/Luan Van/ (07/21/2009)

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